



## Corres. and Mail

## RESPONSE UNDER 37 C.F.R. § 1.116 EXPEDITED PROCEDURE REQUESTED EXAMINING GROUP 2125

PATENT Customer No. 22,852 Attorney Docket No. 07942.0007-00

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

in re Application of:	)
Neal KUO	) Group Art Unit: 2125
Application No.: 09/900,165	) Examiner: Kidest Bahta
Filed: July 9, 2001	) ) )  Confirmation No. 5417
For: METHOD AND SYSTEM FOR DETERRING THE BEST	) )
INTEGRAL PROCESS PATH TO	Mail Stop AF
PROCESS SEMICONDUCTOR	)
PRODUCTS TO IMPROVE YIELD	)

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

## **AMENDMENT AFTER FINAL**

In reply to the Final Office Action mailed February 3, 2005, and pursuant to 37 C.F.R. § 1.116, Applicant proposes that this application be amended as follows:

**Remarks** follow the amendment sections of this paper.